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PATENT
8075-1014

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants: Tsuguo FUKUDA et al. Confirmation: 4391
Serial No.: 10/551,113 Art Unit: 1743
Filed: Sept. 28, 2005 Examiner: Not assigned
For: METHOD FOR ANALYZING IMPURITIES (COLOR CENTERS) OF
FLUORIDE AND PROCESS FOR PRODUCING MATERIAL FOR
GROWING SINGLE CRYSTAL

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 1, 2006

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, included with the attached Form PTO-1449 is the English language translation of the International Preliminary Examination Report (IPER), together with copies of two references that were not cited in the International Search Report included with the Information Disclosure Statement (IDS) filed with the present application on September 28, 2005.

The Examiner is courteously requested to initial and return a copy of the attached Form PTO-1449 to confirm consideration of the references and their entry into the record.

Respectfully submitted,

YOUNG & THOMPSON

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